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I CERTIFY THAT ON JUNE 28, 2002, WHICH IS THE DATE I
AM SIGNING THIS CERTIFICATE, THIS CORRESPONDENCE
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STEVEN W. SMYRSKI

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Group Art Unit: 2878

CHRISTOPHER FAIRLEY, ET AL.

Examiner: Eric J. Spears

Title: CONFOCAL WAFER INSPECTION
METHOD AND APPARATUS

Serial No.: 09/533,203 ✓

Filed: MARCH 23, 2000 ✓

PETITION FOR EXTENSION OF TIME

Asst. Commissioner for Patents
Washington, DC 20231

Sir:

In accordance with Rule 136, Applicant respectfully petitions the Commissioner for
a one month extension of time extending to June 28, 2002, the period for response to the

07/11/2002 ANABII 00000077 09533203

03 FC:115

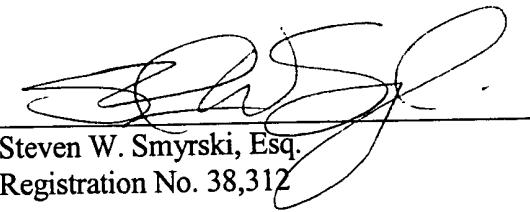
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S/N 09/533,203
Fairley et al.

Atty [REDACTED] No. KLAC0012
Page 2

Office Action dated February 28, 2002. A check for \$110.00 and the responsive papers are attached.

Respectfully submitted,



Steven W. Smyrski, Esq.
Registration No. 38,312

Date: June 28, 2002

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